5 2004				·		
					Docket No. <b>252016-1130</b>	
	missioner for Patents	In re Application of: Chen et al.				
Mail Stop Amendment P.O. Box 1450 Alexandria, VA 22313-1450		Application Number: 09/905,408 Filed: July 16, 2001		3, 2001		
		For: Selective Formation of Metal Gate for Dual Gate Oxide Application				
		Group Art Unit: 2818		Examiner: Berry, Renee		
This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.						
The requested extension and appropriate non-small-entity fee are as follows: (check time period desired):						
	Three months (3)	CFR 1.17(a)(1)) CFR 1.17(a)(2)) B7 CFR 1.17(a)(3)) CFR 1.17(a)(4)) CFR 1.17(a)(5))			\$ 110.00 \$ 420.00 \$ 950.00 \$ 1,480.00 \$ 2,010.00	
	Payment of the Extension of Time appears in the enclosed Amendment Transmittal Letter. At any time during the pendency of this application, please charge any fees required or credit any over payment to Deposit Account pursuant to 37 CFR 1.25.					
		- OR	_			
	\$456.00  The Commissione Account  The Commissione		is attached in the orized to charge or charge any de	e to a Do	es, or	
WA	ARNING: Information on the form. F	nis form may become pub Provide credit card inform	olic. Credit card	l information sho prization on PTO	ould not be included on this -2038.	
Aug 23,7004 Daniel R McClure Reg. No. 38 962						